IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Oleg Siniaguine et al.

Assignee: Tru-Si Technologies, Inc.

Title: Plasma Processing Comprising Three Rotational Motions Of An Article

Being Processed

Application No.: Unassigned Filing Date: Herewith

Examiner: Unknown Group Art Unit: Unknown

Docket No.: M-7554-1D US

San Jose, California July 24, 2003

Mail Stop Patent Application Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 CFR § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are not enclosed as all documents were previously cited by or submitted to the Patent Office in a prior application relied upon for priority under 35 U.S.C. 120(37 C.F.R. § 1.98(d)). Explanation of relevance of the non-English language documents was provided in the prior application. The prior application is U.S. Application No. 09/713,137, filed November 14, 2000.

Citation of these documents shall not be construed as:

- 1. an admission that the documents are necessarily prior art with respect to the instant invention;
 - 2. a representation that a search has been made, other than as described above; or

-1- Application No.: Unknown

3. an admission that the information cited herein is, or is considered to be material to patentability as defined in § 1.56(b).

No fee is believed to be required. If a fee is required for this Information Disclosure Statement, please charge the fee to Deposit Account No. 50-2257. This paper is being submitted in duplicate.

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Respectfully submitted,

Michael Sherkey Michael Shenker

Attorney for Applicant(s)

Reg. No. 34,250

U.S. Department of Commerce, Patent and Trademark Office						Atty Docket No.			Serial No.		
					M-7554-1D US			Unassigned			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Applicant(s)					
(Use several sheets if necessary)						Siniaguine et al.					
						Filing Date			Group		
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	BN							1	
	BQ							1	
	BP							1	
	BQ							1	

citation if not in conformance and not considered. Include copy of this form with your communication to applicant.